

Form PTO-1449
(Rev. 8-83)

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U.S. Department of Commerce
Patent and Trademark Office

Atty Docket 0756-1551

Serial No. 08/691,434

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI et al.

Filing Date: August 02, 1996

Group Art Unit: 2822

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
mw	* 5,294,811	03/15/1994	Aoyama et al.	_____	_____	
mw	5,294,572	03/01/1994	Granneman et al.	_____	_____	
mw	5,308,998	05/03/1994	Yamazaki et al.	_____	_____	
mw	5,620,095-5,620,905	04/15/1997	Konuma et al.	_____	_____	
mw	5,965,904	10/12/1999	Ohtani et al.	_____	_____	
mw	5,996,594	10/12/1999	Adachi et al.	_____	_____	

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
mw	* 0 211 634	02/25/1987	EP	_____	_____	Engl.
mw	* 01-128446	05/22/1989	Japan	_____	_____	Abst.
mw	* 02-257619	10/18/1990	Japan	_____	_____	Abst.
mw	* 04-206532	07/28/1992	Japan	_____	_____	Abst.
mw	* 05-182923	07/23/1993	Japan	_____	_____	Abst.
mw	* 57-194518	11/30/1982	Japan	_____	_____	Abst.
mw	64-076737	03/22/1989	Japan	_____	_____	Abst.

Examiner *Mulcahy*

Date Considered

04/01

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449 (Rev. 8-83)	Department of Commerce Patent and Trademark Office	Atty Docket 0756-1	Serial No. 08/691,434
INFORMATION DISCLOSURE STATEMENT		Applicants: Shunpei YAMAZAKI et al.	
		Filing Date: August 02, 1996 Group Art Unit: 2822	

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
MW	5,966,594 <i>duplicate</i>	10/12/1999	Adachi et al.			



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Examiner <i>Milczewski</i>	Date Considered <i>04/01</i>
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For
(Rev.)U.S. Department of Commerce
Patent and Trademark Office

Atty Docket 0756-155

Serial No. 08/691,434

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI et al.

Filing Date: August 02, 1996

Group Art Unit: 2822

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FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes	Translation No
MW	03-293719	12/25/1991	JP	1		Eng Abst	
MW	04-152624	05/26/1992	JP	1		Eng Abst	
MW	04-240733	08/28/1992	JP	1		Eng Abst	
MW	04-373178	12/25/1992	JP	1		Eng Abst	
MW	05-243577	09/21/1993	JP	1		Eng Abst	
MW	05-251342	09/28/1993	JP	1		Eng Abst	
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MW	06-084944	03/25/1994	JP	1		Eng Abst	
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MW	60-066471	04/16/1985	JP	1		Eng Abst	
MW	63-250178	10/18/1988	JP	1		Eng Abst	
MW	64-057615	03/03/1989	JP	1		Eng Abst	

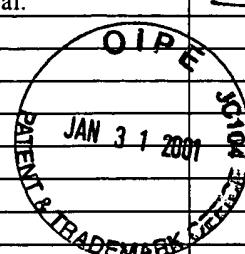
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Examiner M.WilczewskiDate Considered 04/01

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Form PTO-1449 (Rev. 8-83)		U.S. Department of Commerce Patent and Trademark Office		Attorney Docket No.: 0756-1551		Application No.: 08/691,434	
INFORMATION DISCLOSURE STATEMENT							
(Use several sheets if necessary)							
Applicants: Shunpei YAMAZAKI							
Filing Date: August 2, 1996 Art Unit: 2822							
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)	
<i>MW</i>	5,648,276	07/15/1997	Hara et al.				
							
FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation Yes No	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>MW</i>	Stanley Wolf, "Silicon Processing For The VLSI Era, Vol. 3: The Submicron Mosfet," pp. 502-504						
<i>MW</i>	Stanley Wolf, "Silicon Processing For The VLSI Era, Vol. 1: Process Technology," pp. 57-58						
Examiner	<i>Milicewski</i>		Date Considered		<i>04/01</i>		
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